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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10025783	FILING DATE 12/26/2001	CLASS 430	SUBCLASS 5	GAU 1756	EXAMINER
APPLICANTS: Watanabe Miroru;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A CON OF 09/443,500 11/19/1999 US 6,373,389					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB DO NOT PUBLISH <input type="checkbox"/> RESCIND <input type="checkbox"/>					
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials:				ATTORNEY DOCKET NO MAE 223 C1	
TITLE : Method and apparatus for forming resist pattern					

U.S. DEPT. OF COMMERCE PAT. & TM. PTO-436 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED 4-1403		Assistant Examiner		CLAIMS ALLOWED Total Claims 26 24 Print Claim for 0.6 1	
ISSUE FEE Amount Due 0 Date Paid		KATHLEEN DUDA PRIMARY EXAMINER Kathleen Duda Primary Examiner		DRAWING Sheets Drwg. 4 Figs. Drwg. 16 Print Fig. 2E	
<input checked="" type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Sias Application Examiner	
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